Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/500,860	SHIMIZU ET AL.	
Examiner	Art Unit	
Hao M. Hyoon	2820	

SEARCHED				
Class	Subclass	Date	Examiner	
439	660	1/65	hmh	
439	74			
439	736			
29	876			
29	883	1/	V	
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Plus Search Done	1/05	hanh		
29/837 & 842 Cursory				
Text Search Done				
Consulted with Exmr Arbes in class 29	V	V		